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## BIB DATA SHEET

CONFIRMATION NO. 7236

<b>SERIAL NUMBER</b> 10/554,380	<b>FILING or 371(c) DATE</b> 09/29/2006 <b>RULE</b>	<b>CLASS</b> 430	<b>GROUP ART UNIT</b> 1795	<b>ATTORNEY DOCKET NO.</b> SHIGA7.032APC
<b>APPLICANTS</b> Takuma Hojo, Kawasaki-shi, JAPAN; Kiyoshi Ishikawa, Kawasaki-shi, JAPAN; Tsuyoshi Nakamura, Kawasaki-shi, JAPAN; Tasuku Matsumiya, Kawasaki-shi, JAPAN;				
<b>** CONTINUING DATA *****</b> This application is a 371 of PCT/JP04/05804 04/22/2004				
<b>** FOREIGN APPLICATIONS *****</b> JAPAN 2003-125241 04/30/2003				
<b>** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **</b> 11/21/2006				
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and Acknowledged <u>/ANCA EOFF/</u> Examiner's Signature	<input type="checkbox"/> Met after Allowance Initials	<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWINGS</b> 0	<b>TOTAL CLAIMS</b> 13
<b>INDEPENDENT CLAIMS</b> 1				
<b>ADDRESS</b> KNOBBE MARTENS OLSON & BEAR LLP 2040 MAIN STREET FOURTEENTH FLOOR IRVINE, CA 92614 UNITED STATES				
<b>TITLE</b> Positive photoresist composition and method for forming resist pattern				
<b>FILING FEE RECEIVED</b> 1030	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	